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RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 3723

#8/1pt & Bde

PATENT
DOCKET No.: 29273/516

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Shigeo MORIYAMA, et al.

SERIAL NO. : 09/462,912

FILED : January 18, 2000

FOR : POLISHING APPARATUS AND METHOD FOR PRODUCING
SEMICONDUCTORS USING THE APPARATUS

ART UNIT : 3723

EXAMINER : Willie Berry, Jr.

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ASSISTANT COMMISSIONER FOR
PATENTS AND TRADEMARKS
Washington, D.C. 20231

gw 04-24-02

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RESPONSE UNDER 37 C.F.R. § 1.116

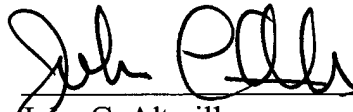
SIR:

In response to the Final Rejection October 22, 2001, the period for response having been extended herein to April 22, 2002 by payment of the requisite fee of \$920.00 for a Petition for Extension of Time Under 37 C.F.R. § 1.136(a), it is respectfully requested that the following amendments be entered to place this application in condition for allowance or better form for appeal:

04/22/2002 CNGUYEN 00000007 110600 09462912
01 FC:117 920.00 CH

The Office is hereby authorized to charge the fee of \$920.00 for a Petition for Extension of Time Under 37 C.F.R. § 1.136(a) and any additional fees under 37 C.F.R. § 1.16 or § 1.17 or credit any overpayment to Deposit Account No. 11-0600.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "John C. Altmiller", written over a horizontal line.

John C. Altmiller

Registration No. 25,951

Dated: April 18, 2002

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